## Facile and sustainable technique to produce low-cost high surface area mangosteen shell activated carbon for supercapacitors applications

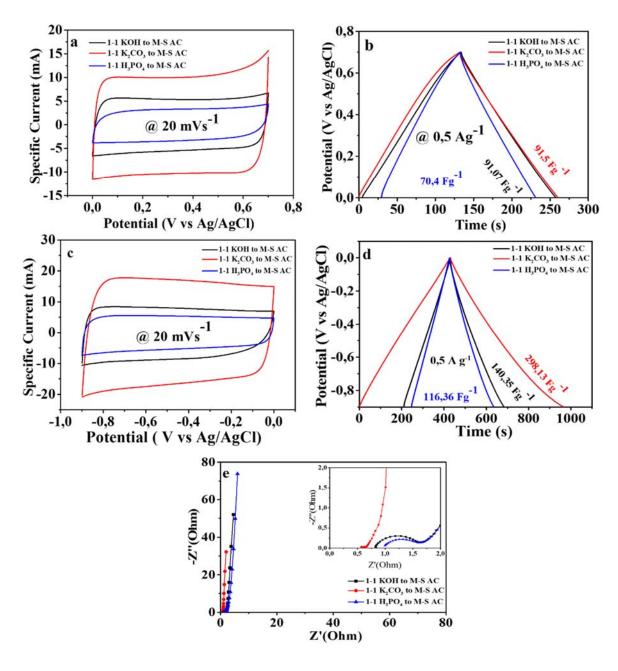
V.N Kitenge<sup>a,b</sup>, D.J Tarimo<sup>b</sup>, K.O Oyedotun<sup>b</sup>, G. Rutavi<sup>b</sup> and N. Manyala\*<sup>b</sup>

<sup>a</sup>Department of Chemical Engineering, University of Pretoria, Pretoria 0028, South Africa.

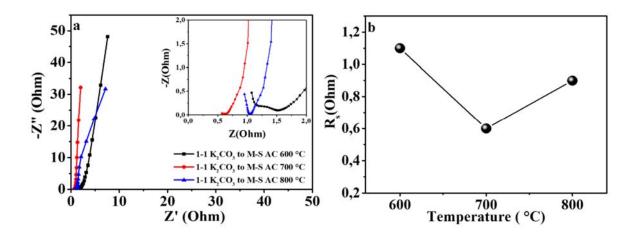
<sup>b</sup>Department of Physics, Institute of Applied Materials, SARChI Chair in Carbon Technology and Materials, University of Pretoria, Pretoria 0002, South Africa.

\*Corresponding authors' email: ncholu.manyala@up.ac.za

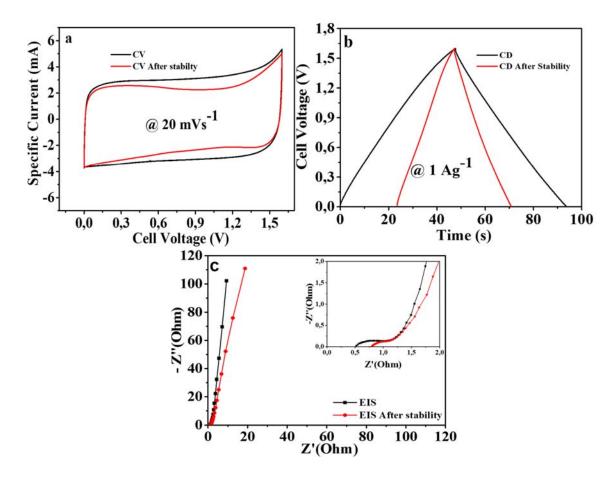
**Supporting Information:** 



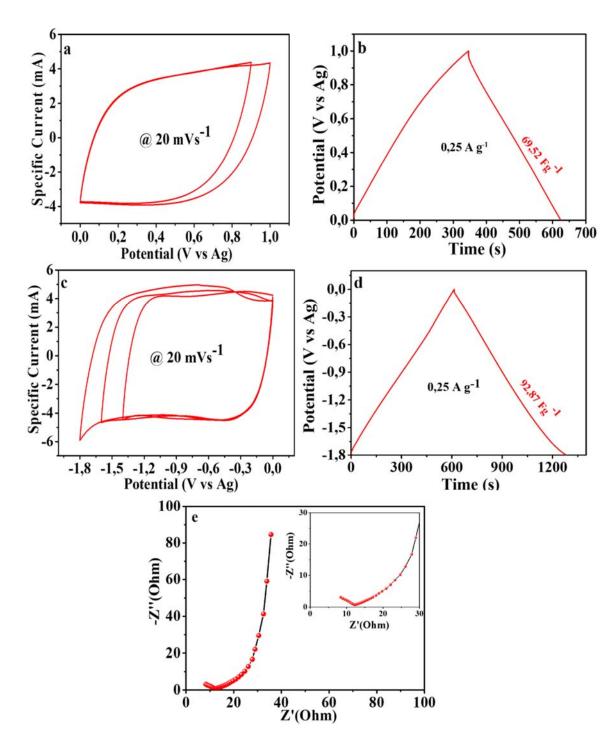
**Figure S 1:** (a, c) CV patterns at 20 mV s<sup>-1</sup>, and (b, d) GCD patterns at 0.5 A g<sup>-1</sup> for the positive and negative electrode, respectively. (c) EIS Nyquist plot, with the inset showing low-frequency region evaluated from different activating agent in 2.5 M KNO<sub>3</sub> as the electrolyte



**Figure S 2:** (a) EIS Nyquist plot, with the inset showing low-frequency region and, (b) Electrical series resistance for 1-1 K<sub>2</sub>CO<sub>3</sub> samples evaluated from different temperature.



**Figure S 3:** Electrochemical characterisation before and after stability: (a) CV curves, (b) GCD curves, and (c) EIS Nyquist plot obtained by using 2.5 M KNO<sub>3</sub>.



**Figure S 4**: (a and c) Positive and negative electrode CV curves at different potentials vs. Ag, (c and d) Positive and negative electrode GCD curves, (e) EIS Nyquist plot with the inset showing low-frequency region for the optimised potentials vs. Ag at 0.25 A g<sup>-1</sup> obtained by using Emi-FSI in a three electrode measurement.

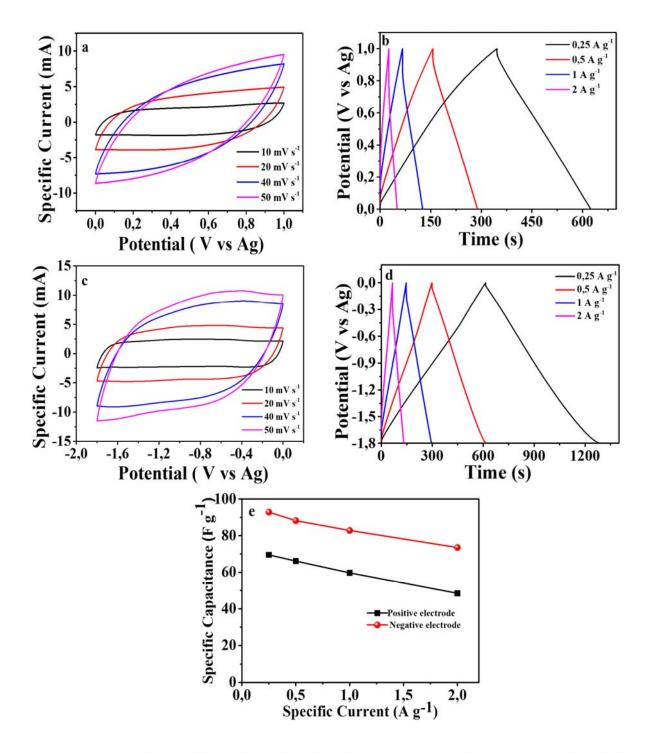


Figure S 5: (a, and c) Positive and negative electrode CV curves at various scan rates, (b, and d) Positive and negative electrode GCD curves at distinct specific currents, and (e) specific capacitance versus specific current for 1:1 K<sub>2</sub>CO<sub>3</sub> to M-S AC obtained by using Emi-FSI.